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Customer No).	026418						
FERNISTO-1390		Transmittal Letter to the United States Designated/Elected Office (DO/EO/US)						
Attorney's Docket No.:		JG-SU-5224/500577.20073						
U.S. Application No.:		10/562235						
International Ap	plication No.:	PCT/JP2005/006268						
International Fil	ing Date:	MARCH 31, 2005	31 MARCH 2005					
Priority Date Claimed:		APRIL 05, 2004	04 APRIL 2004					
Title of Inventio	n:	MANUFACTURING METHOD OF SEMICONDUCTOR WAFER AND						
		SEMICONDUCTOR WAFER MANUFACTURED BY THIS METHOD						
Applicant(s) for	(DO/EO/US):	Syouji NOGAMI, Yukichi HORIOKA, and Shoichi YAMAUCHI						
Applicant here	ewith submits to	the United States Designated/Elected Office (DO/EC	O/US) the following items and other information:					
[] 2. This [] 3. This (6), (6), (7), (7), (7), (7), (7), (7), (7), (7	is a SECOND of express reques (9), and (21) ind US has been e py of Publication (a) [] has c) [] has considered (b) [] has ndments to the a) [] has considered (c) [] has consid	lected (Article 31). In No. WO 2005/098912 200CT05 the International Actached hereto (required only if not communicated by seen communicated by the international Bureau. Not required, as the application was filed in the United the translation of Publication No. WO 2005/098912 200 attached hereto attached hereto been previously submitted under 35 U.S.C. 154(d)(4) claims of the International Application under PCT Article attached hereto (required only if not communicated by the been communicated by the international Bureau. We not been made; however, the time limit for making seen to be made and will not be made translation of the amendments to the claims under Fight or declaration of the inventor(s) [35 U.S.C. 371(c)(4) the translation of the annexes to the International Preliminational	iling under 35 U.S.C. 371. 2. 371 (f)]. The submission must include items (5), Application as filed [35 U.S.C. 371(c)(2)] by the International Bureau). States Receiving Office (RO/US) OCT05 the International Application as filed [35). icle 19 [35 U.S.C. 371(c)(3)] by the International Bureau). such amendments has NOT expired. PCT Article 19 [35 U.S.C. 371(c)(3)] 1) TO FOLLOW LATER					
! !		cern other document(s) or information included:						
[] \$2. An A inclu [X] 13. A pr [] 14. An A [X] 15. A su [] 16. A ch [] 17. A co [] 18. A se [] 19. A se [X] 20. (other 24J)	assignment doc ded. eliminary ame application Data bstitute speci ange of power mputer-readable cond copy of the cond copy of the er items or infor	indicate the sequence of a separate cover sheet (PTO-15) and the sequence of attorney and/or address letter e form of the sequence listing in accordance with PCT e published International Application under 35 U.S.C. e English language translation of the International Application) PCT forms: PCT easy in English and J 8/308 10NOV05, Japanese Search Report: PCT	amendment) T Rule 13 <i>ter.</i> 2 and 35 U.S.C. 1.821-1.825. 154 (d)(4). plication under 35 U.S.C. 154 (d)(4). lapanese, PCT/IB/301 13MAY05, PCT/IB/304					
w/3	documents							

EXPRESS MAIL No.: EL 962 858 663 US Deposited: December 22, 2005 I hereby certify that this correspondence is being deposited with the United States Postal Service Express mail under 37 CFR 1.10 on the date indicated above and is addressed to: Mail Stop PCT, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313 1450

/Ruth Montalvo Date: December 22, 2005

10/562235

IAPS Rec'd PCT/PTO 22 DEC 2009 Page 2

U.S. Application No. International Applicat				•		Attorney's Docket		
The following fees				_		thorney 5 Docket	Applicant use	Office use only
			92(a))			\$ 300.00	\$ 300.00	
[X] 21 Basic national fee (37 CFR 1.492(a)) \$ 300.00 [X] 22 Examination fee (37 CFR 1.492(b)) If the written opinion prepared by ISA/US or the International Preliminary Examination report prepared by IPEA/US indicates all claims satisfy provisions of PCT Articles 33(1)-(4) \$ 0.00 All other situations							\$ 200.00	
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Independent Claims:		· ·	1	- 3	0	X \$ 200.00	\$	
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[] Applicant claims S	mall Entity	Status [See	37 CFR 1.27]	Reduction	on by ½ for filing by small			
						SUBTOTAL:	\$1,200.00	
Processing fee of \$1 claimed priority date			English Trans	slation lat	er than [] 20 [] 30 mont	ns from the earliest +		
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Jules E. Goldberg, E Reed Smith LLP	Esq.	(Customer No.	. 026418)		Signature:		CP0.00	ln
599 Lexington Avenu New York, NY 10022					Attorney:	Jules E. Goldbe	erg	C
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li e	THE UNITED STATES PATENT	AND TRADEMARK OFFICE			
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Syouji NOGAMI, Yukichi HORIOKA, and Shoichi YAMAUCHI MANUFACTURING METHOD OF SEMICONDUCTOR WAFER AND
SEMICONDUCTOR WAFER MANUFACTURED BY THIS METHOD

This is to acknowledge receipt of the following:

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Translation of Publication No. WO 2005/098912, Preliminary Amendment
(#24/1) w/Substitute Specification & Abstract and Marked-up/Bolded Versions;
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EXECUTED Declaration/POA - TO FOLLOW LATER

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